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Bib Data Sheet

SERIAL NUMBER 09/977,238	FILING DATE 10/16/2001 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. SEC.895
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APPLICANTS

BL Chung-Sam Jun, Hwasung-gun, KOREA, REPUBLIC OF;
 Sang-Mun Chon, Seongnam-si, KOREA, REPUBLIC OF;
 Sang-Bong Choi, Suwon-si, KOREA, REPUBLIC OF;
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 Sang-Min Kim, Seoul, KOREA, REPUBLIC OF;
 Sang-Kil Lee, Suwon-si, KOREA, REPUBLIC OF;

** CONTINUING DATA ***** NO

** FOREIGN APPLICATIONS *****

BL REPUBLIC OF KOREA 2000-61717 10/19/2000 YES

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 11/15/2001

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 21	TOTAL CLAIMS 31	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature Initials				

ADDRESS

JONES VOLENTINE, P.L.L.C.
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 Reston , VA 20191

TITLE

Method and apparatus for numerically analyzing grain growth on semiconductor wafer using SEM image

FILING FEE RECEIVED 1022	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other <input type="checkbox"/> Credit
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